



Set for 3/3
PATENT
Attorney Docket No.: NICHIA-00800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 2825
Shinichi Nagahama *et al.*)
Serial No.: 09/500,288) Examiner:
Filed: February 8, 2000)
For: **NITRIDE SEMICONDUCTOR**) **RESPONSE TO NOTICE TO FILE**
DEVICE AND MANUFACTURING) **MISSING PARTS OF APPLICATION**
METHOD THEREOF) 260 Sheridan Avenue, Suite 420
) Palo Alto, CA 94306
) (650) 833-0160

Box Missing Part

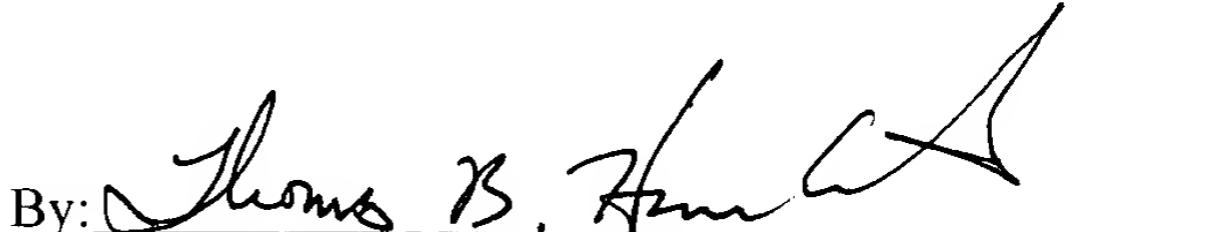
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Notice to File Missing Parts of Application -- Filing Date Granted (Form PTO-1533) mailed April 19, 2000 (a copy of which is enclosed), applicants submit the enclosed verified english translation, certified copies of the priority documents (11-030990 and 11-331797) and a check in the amount of \$130.00 to cover the surcharge for filing missing parts of an application for filing with the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment to Deposit Account No. 08-1290. An **originally executed duplicate of this transmittal is enclosed for this purpose.**

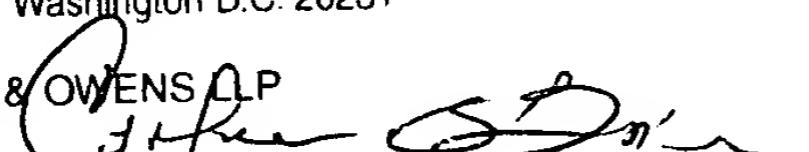
Respectfully submitted,
HAVERSTOCK & OWENS LLP

By: 
Thomas B. Haverstock
Reg. No.: 32,571
Attorneys for Applicant(s)

Dated: 4-25-00

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington D.C. 20231

Date: 4/26/00 By: 
HAVERSTOCK & OWENS LLP

FORMALITIES LETTER



OC00000005060601
UNITED STATES DEPARTMENT OF
COMMERCE
Patent and Trademark OfficeAddress: COMMISSIONER OF PATENT AND TRADEMARKS
Washington, D.C. 20231

APPLICATION NUMBER	FILING/RECEIPT DATE	FIRST NAMED APPLICANT	ATTORNEY DOCKET NUMBER
09/500,288	02/08/2000	Shinichi Nagahama	NICHIA-00800

Haverstock & Owens LLP
260 Sheridan Avenue
Suite 420
Palo Alto, CA 94306

Date Mailed: 04/19/2000

NOTICE TO FILE MISSING PARTS OF NONPROVISIONAL APPLICATION

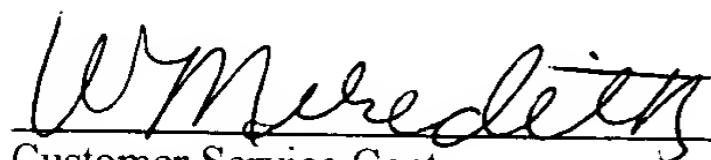
FILED UNDER 37 CFR 1.53(b)

Filing Date Granted

An application number and filing date have been accorded to this application. The item(s) indicated below, however, are missing. Applicant is given TWO MONTHS from the date of this Notice within which to file all required items and pay any fees required below to avoid abandonment. Extensions of time may be obtained by filing a petition accompanied by the extension fee under the provisions of 37 CFR 1.136(a).

- The application was filed in a language other than English.
- Applicant must file an English translation of the application, the \$ 130 fee set forth in 37 CFR 1.17(k), unless previously submitted, and a statement that the translation is accurate (37 CFR 1.52(d)).
- The balance due by applicant is \$ 130.

*A copy of this notice **MUST** be returned with the reply.*



Customer Service Center

Initial Patent Examination Division (703) 308-1202

PART 1 - ATTORNEY/APPLICANT COPY

05/03/2000 Y6IZAY 00000081 09500288

01 FC:105

130.00 0P



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Shinichi NAGAHAMA et al.

Serial No. 09/500,288 : Attn: **BOX MISSING PARTS**

Filed February 8, 2000 : Docket No. NICHIA-00800

**NITRIDE SEMICONDUCTOR DEVICE
AND MANUFACTURING METHOD
THEREOF**

TRANSLATOR'S DECLARATION

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

I, Hisao ISHII, declare:

that I am thoroughly familiar with both the Japanese and English languages;
that the attached document represents a true English translation of U.S. Patent
Application Serial No. 09/500,288 filed February 8, 2000; and

That I further declare that all statements made herein of my own knowledge are
true and that all statements made on information and belief are believed to be true; and
further that these statements were made with the knowledge that willful false statements
and the like so made are punishable by fine or imprisonment, or both, under Section
1001 of Title 18 of the United States Code, and that such willful false statements may
jeopardize the validity of the application or any patent issuing thereon.

April 24, 2000

DATE


TRANSLATOR'S SIGNATURE